

**Amendments to the Specification:**

Please replace the paragraph beginning on page 6, line 16 and ending on page 6, line 21 with the following paragraph:

The sealing frames and flow fields are formed as previously discussed. The sealing frames may be bonded by methods selected from, for example, heat welding, chemical welding, adhesives, and combinations thereof. [[Casketing]] Gasketing surfaces may be used to create fluid tight seals between components that are not otherwise bonded. As above, the anode fluid barrier overlaps the anode sealing frame and the cathode fluid barrier overlaps the cathode sealing frame only a sufficient amount to create a fluid-tight seal.